



11-24-04

AF/2811
JFV
A

Filed Via Express Mail pursuant to 37 C.F.R. 1.10

Rec. No.: EV 479 701 326 US

On: NOVEMBER 23, 2004

By:

LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

Attorney Docket No.: NECF 18.591 (100806-17366)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Takaaki NAGAI

Serial No.: 09/837,734

Filed: April 17, 2001

Title: **NON-VOLATILE SEMICONDUCTOR STORAGE
APPARATUS AND MANUFACTURING METHOD THEREOF**

Examiner: Douglas W. Owens

Group Art Unit: 2811

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

SIR :

In response to the Office Action dated August 23, 2004, the period for responding thereto
expiring after November 23, 2004, please amend the subject application as follows: